

Docket No.: 061282-0048



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Customer Number: 20277

Shinya TOKUNAGA, et al.

Confirmation Number: 4744

Application No.: 10/722,346

Group Art Unit: 2825

Filed: November 26, 2003

Examiner: SIEK, VUTHE

For: MASK PATTERN INSPECTING METHOD, INSPECTION APPARATUS, INSPECTING

DATA USED THEREIN AND INSPECTING DATA GENERATING METHOD

OK to enter

RESPONSE UNDER 37 C.F.R. § 1.111

5115/06

Mail Stop Amendment Honorable Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to Office Action dated February 6, 2006, having a shortened statutory period for response set to expire on Saturday, May 6, 2006, Applicants respectfully request reconsideration of the pending rejection for the following reasons.